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## BIB DATA SHEET

CONFIRMATION NO. 4192

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/590,067	08/21/2006	451	3724	8279.1153USWO
<b>RULE</b>				
<b>APPLICANTS</b> Tetsuo Shimomura, Osaka-shi, JAPAN; Atsushi Kazuno, Osaka-shi, JAPAN; Kazuyuki Ogawa, Osaka-shi, JAPAN; Yoshiyuki Nakai, Osaka-shi, JAPAN; Masahiko Nakamori, Ohtsu-shi, JAPAN; Takatoshi Yamada, Ohtsu-shi, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP05/02785 02/22/2005				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2004-46411 02/23/2004				
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 04/26/2007				
Foreign Priority claimed 35 USC 119(a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No /TIMOTHY V ELEY/ Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 0
			<b>TOTAL CLAIMS</b> 7	<b>INDEPENDENT CLAIMS</b> 1
<b>ADDRESS</b> HAMRE, SCHUMANN, MUELLER & LARSON, P.C. P.O. BOX 2902 MINNEAPOLIS, MN 55402-0902 UNITED STATES				
<b>TITLE</b> Polishing pad and method for manufacture of semiconductor device using the same				
<b>FILING FEE RECEIVED</b> 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit